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	Application No.	Applicant(s)		
Notice of Allowability	0/724,982	HAMPTON, KEVIN	HAMPTON, KEVIN WADE	
	xaminer	Art Unit		
	David Nhu	2818		
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (C herewith (or previously mailed), a Notice of Allowance (PTOL-85) or NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIG of the Office or upon petition by the applicant. See 37 CFR 1.313 a	OR REMAINS) CLOSED in the commendate commendate commendates. This application is	n this application. If not includ nunication will be mailed in due	led course. THIS	
1. This communication is responsive to <u>11/30/03</u> .				
2. ☑ The allowed claim(s) is/are <u>1-19</u> .				
3. $igotimes$ The drawings filed on <u>07 May 2004</u> are accepted by the Exam	miner.			
 4. Acknowledgment is made of a claim for foreign priority under a) All b) Some* c) None of the: Certified copies of the priority documents have been copies of the priority documents have been copies of the certified copies of the priority documents have been copies of the certified copies of the priority documents have been copies of the certified copies of the priority documents have been copies of the certified copies of the priority documents have been copies of the certified copies of the priority documents have been certified copies. 	een received een received in Applicati ments have been receive this communication to fil	on No ed in this national stage applica		
 A SUBSTITUTE OATH OR DECLARATION must be submitted INFORMAL PATENT APPLICATION (PTO-152) which gives 			NOTICE OF	
6. ☐ CORRECTED DRAWINGS (as "replacement sheets") must t	oe submitted.			
(a) \square including changes required by the Notice of Draftsperson	n's Patent Drawing Revie	w (PTO-948) attached		
1) hereto or 2) to Paper No./Mail Date				
(b) including changes required by the attached Examiner's A Paper No./Mail Date	Amendment / Comment o	or in the Office action of		
Identifying indicia such as the application number (see 37 CFR 1.84 each sheet. Replacement sheet(s) should be labeled as such in the	(c)) should be written on header according to 37 C	the drawings in the front (not the FR 1.121(d).	e back) of	
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT FO 	OF BIOLOGICAL MAT OR THE DEPOSIT OF B	ERIAL must be submitted. OLOGICAL MATERIAL.	Note the	
Attachment(s)				
1. Notice of References Cited (PTO-892)		nformal Patent Application (PT	O-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ∐ Interview S Paper No	Summary (PTO-413), ./Mail Date		
3 Information Disclosure Statements (PTO-1449 or PTO/SR/08)	7 Evaminer's	Amendment/Comment		

XAW OR IN

Paper No./Mail Date

of Biological Material

4.

Examiner's Comment Regarding Requirement for Deposit

8.

Examiner's Statement of Reasons for Allowance

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REASONS FOR ALLOWANCE

1. Claims 1-19 are allowed.

- 2. The following is an examiner's statement of reasons for allowance: None of the references of record teaches or suggests as cited in claims 1: curing the substrate bonding material to secure the plurality of die to the substrate; covering the substrate and the plurality of die with a mask material; applying a back grinding tape to a surface of the mask material; grinding the substrate and the plurality of die to thin the plurality of die; applying ultraviolet (UV) transfer tape to the die on a film frame; removing the mask material and back grinding tape residue; placing the plurality of die, UV transfer tape, and film frame face down in a UV cure station; UV irradiating the UV transfer tape; removing the plurality of die from the UV transfer tape.
- 3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

CONCLUSION

- 4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure: Runyon et al (6,582,983 B1): Method and Wafer for Maintaining Ultra Clean Bonding Pads on a Wafer.
- 5. Any inquiry concerning this communication on earlier communications from the examiner should be directed to David Nhu, (571)272-1792. The examiner can normally be reached on Monday-Friday from 7:30 AM to 5:00 PM.

The examiner's supervisor, David Nelms can be reached on (571)272-1787.

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The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956

David Nhu

Dal

November 15, 2004

DAVID NHU PRIMARY EXAMINED